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SKJERVEN  
MORRILL  
MACPHERSON LLP

Docket No.: M-10693 US

June 26, 2001

U.S. PTO  
09/891693  
06/26/01

Box Patent Application  
Commissioner For Patents  
Washington, D. C. 20231

Enclosed herewith for filing is a patent application, as follows:

Inventors: Steve Biellak, Stanley E. Stokowski and Mehdi Vaez-Iravani

Title: **SYSTEMS AND METHODS FOR A WAFER INSPECTION SYSTEM USING  
MULTIPLE ANGLES AND MULTIPLE WAVELENGTH ILLUMINATION**

☒ Return Receipt Postcard  
☒ This Transmittal Letter (in duplicate)  
14 pages Specification (not including claims)  
8 pages Claims  
1 page Abstract  
3 Sheets of Drawings  
4 pages Declaration For Patent Application and Power of Attorney  
1 page Recordation Form Cover Sheet (in duplicate)  
2 pages Assignment  
3 pages Information Disclosure Statement and PTO Form 1449 citing 21 references  
☒ Copies of 21 Cited References submitted

**CLAIMS AS FILED**

For	Number Filed		Number Extra		Rate		Basic Fee
Total Claims	45	-20 =	25	x	\$ 18.00	=	\$ 450.00
Independent Claims	4	-3 =	1	x	\$80	=	\$ 80.00
<input type="checkbox"/> Fee of _____ for the first filing of one or more multiple dependent claims per application							\$
<input type="checkbox"/> Fee for Request for Extension of Time							\$

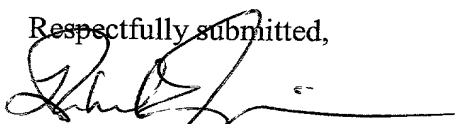
Please make the following charges to Deposit Account 19-2386:

☒ Total fee for filing the patent application in the amount of \$ 1,240.00  
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account 19-2386.

EXPRESS MAIL LABEL NO:

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Respectfully submitted,



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